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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kiyoshi ARITA et al.

Serial No.: 10/085,128

Group Art Unit: 1762

Filed: March 1, 2002

For: PLASMA PROCESSING METHOD

STATUS INQUIRY LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

It would be appreciated if you would indicate the status of the above-identified application below, including an indication as to when the next communication can be expected, and return this sheet to the undersigned.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

January 20, 2004

Date

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